Induction-heated nanoimprint on soda-lime glass using sapphire molds

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The authors developed an induction-heated high-temperature thermal nanoimprint process to directly transfer nanoscale features on sapphire molds to soda-lime glass substrates. Nanoholes of a 650-nm-period hexagonal lattice were directly imprinted in soda-lime glass using the induction-heated thermal nanoimprint configuration as an experimental demonstration. The morphology of nanostructures imprinted on glass substrates at different imprinting process parameters was characterized by scanning electron microscopy and atomic force microscopy and further numerically investigated using a finite element method. The soda-lime glass substrates imprinted with nanohole arrays were then used as secondary templates for further transferring nanostructures onto cyclic olefin copolymer films through another thermal nanoimprint process. The authors also demonstrated surface-enhanced Raman spectroscopy sensing applications on these nanostructured glass substrates after coating them with a thin layer of gold. © 2016 American Vacuum Society.

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I. INTRODUCTION

Glass is widely used as device substrates or structural materials in many emerging applications in the fields of electronics,1 photonics,2 microfluidics,3 and photovoltaics,4 mainly for its high chemical and heat resistance, excellent electrical isolation, high optical transmission in a wide spectral range, low color aberration, and good biocompatibility. Because many of these applications need micro- or nanoscale structures on a substrate surface, development of a suitable process for creating these structures on glass substrates has become increasingly important. Conventional surface structuring of glass can be performed by photolithography and etching5 or micromachining.6 However, most of these processes are either expensive or in the lack of high resolution for nanostructures.

As a low-cost, high-resolution and large-area mechanical patterning method, nanoimprint lithography (NIL) has received significant development over the past 20 years.7 It has the capability to replicate sub-10 nm features8 with alignment9 and even complex three-dimensional structures10 by directly deforming the substrate material and is now increasingly used in many emerging optical applications. However, directly nanoimprinting on glass substrates is still challenging because the molding temperature of typical glass substrates is usually above 500 °C, which is much higher than the imprinting temperature for thermoplastic substrates. A reliable and compact fast heating source is desirable for high-temperature nanoimprinting on glass substrates. Moreover, selection of mold materials suitable for imprinting glass under such high temperature and development of a reliable and optimized fabrication process are key issues to be resolved. Conventional silicon-based molds used for NIL have strong adhesion to commonly used SiO2-containing glass substrates after high-temperature imprinting, which will increase the risk of mold failure during the nanoimprint and separation process. Directly imprinting on glass substrates has been reported by researchers. Nanostructures have been patterned on low-Tg glass using a Si3N4/SiO2/Si mold,11 where the Si3N4 coating is used to physically isolate SiO2-containing glass substrate and SiO2/Si mold. Other mold materials, including glassy carbon,6 NiO,12 and CVD diamond,13 are also employed in the demonstration of nanoimprinting on glass substrates. However, many of the reported studies so far mainly involved rather large structures of a few micrometers or specific low-melting-temperature glass and general modeling for understanding the deformation mechanism during the imprinting process on glass substrates still need further investigation.

In this research, we first developed an induction-heated high-temperature thermal NIL process for replicating nanoscale structures on the most commonly used soda-lime glass using sapphire molds. Induction heating process provides many technological and economic merits in comparison with conventional resistive-heating hot plates for its fast heating rate, high achievable processing temperature, high efficiency, instant controllability, low cost, and compact configuration.14 On the other hand, sapphire molds exhibit reliable separation from SiO2-containing glass without additional treatment during experiments. Sapphire molds have previously been used to imprint nanoscale structures on glassy substrates;15–18 however, to our best knowledge, high-temperature (e.g., higher than 700 °C) thermal nanoimprinting of high-aspect-ratio...
nanostructures on soda-lime glass using sapphire molds have not been reported yet. Here, nanoholes of approximately 200 nm diameter in a 650-nm pitch hexagonal array were imprinted on soda-lime glass substrates using a sapphire mold carrying the original nanopillar array structure. The effects of imprinting processing parameters, including imprinting temperature and pressure, on the depth of imprinted structure and pattern transfer fidelity, were numerically and experimentally investigated. Then, we used the nanostructured glass substrates as secondary imprinting templates and further transferred the nanostructures into cyclic olefin copolymer (COC) thermoplastic films through another thermal NIL process. Moreover, we also demonstrated potential surface-enhanced Raman sensing (SERS) applications using the nanoimprinted glass substrates after evaporating a thin layer of gold to make them SERS-active.

II. EXPERIMENT

Soda-lime glass slides (CAT. 7107P, Fan Yi, China) were cut into 2 × 2 cm pieces. These glass pieces were first cleaned with a cotton swab and rinsed thoroughly in deionization (DI) water, and then treated with oxygen plasma (Potentlube, China) for 10 min. The samples were then further cleaned by ultrasonication in isopropanol and DI water for 30 s before dried in nitrogen. The mold used in this work was a sapphire mold with a 650-nm pitch hexagonal array of nanopillars. The sapphire mold was replicated from a silicon master mold fabricated using interference lithography, e-beam evaporation, and reactive ion etching.

Figure 1 schematizes our work demonstrated in this paper. Initially, circular nanoholes in a 650-nm-pitch hexagonal array were replicated from the sapphire mold to soda-lime glass substrates by a home-built induction-heated thermal nanoimprint setup. Then, the nanostructured soda-lime glass substrates were used as templates for two different applications. First, the glass substrates patterned with nanohole arrays were used as secondary molds to reversely replicate nanopillars on COC films (Grade 8007, TOPAS Advanced Polymers) by a conventional thermal NIL process. Second, in another application demonstration, the nanostructured glass substrates were coated with a thin gold layer to convert them into SERS-active substrates for Rhodamine 6G (R6G) sensing. The details of the experiments are presented in Secs. II A–II C.

A. Induction-heated thermal nanoimprint on soda-lime glass substrates

A home-built induction-heated thermal nanoimprint setup was used to pattern the soda-lime glass substrates with nanostructures. The setup consisted of a 3.5-cm diameter, 2.5-cm height cylindrical 2Cr13 ferromagnetic stainless steel press for heat generation by induction, a digital force gauge (Aliyiqi, China) to apply and measure the imprinting pressure, a set of induction heater with a 40-mm diameter brass coil and a HD2440-2 switching power supply (Emerson) to provide 27 V for the heater.

The imprinting process is schematically described in Figs. 2(a)–2(e). In a typical imprinting process, a cleaned soda-lime glass substrate was first covered by a sapphire mold and supported by another cleaned flat sapphire plate to isolate the glass substrate from the stainless steel press [Fig. 2(a)]. In the following step, the whole stack was placed in the press and heated by a 650 W induction heater [Fig. 2(b)]. After approximately 2 min, the setup was heated to 820°C (90°C above the softening point of the soda-lime glass), and set imprinting pressure was applied [Fig. 2(c)]. The induction heater was then powered off, and the system was cooled in the ambient environment. The imprinting pressure was maintained during the whole imprint process until the temperature was lower than the annealing point of the soda-lime glass. Finally, the mold and the substrate can be separated manually after the stack is cooled down to room temperature [Fig. 2(d)]. The general sequence of heating and pressing is summarized in Fig. 2(e). Figure 2(f) shows the thermocouple-measured temperature in the setup as a function of imprinting time during a typical imprinting process. With the compact configuration, it costs approximately 2 min to cool the system down to the demolding temperature. The cooling process can be accelerated if an external forced cooling device, e.g., a water circulation chiller, is applied. With further optimization, our induction-heated imprint process would be capable of high throughput fabrication of nanostructured soda-lime glass substrates.

In all the experiments presented in this work, sapphire molds were not treated with any antisticking layer, since the antisticking agent cannot withstand such high temperature and sapphire molds showed excellent nature for separation from imprinted glass substrates. The characterizations of samples were performed using Hitachi S-4800, LEO 1530 SEMs, and a Bruker MultiMode-8 AFM.
B. Pattern transfer on plastic films using directly imprinted glass templates

Glass substrates patterned with nanohole arrays, fabricated through the aforementioned induction-heated imprint process, were used as secondary templates in subsequent replication process on COC films. The glass template was positioned on top of a cleaned COC film and then placed in a nanoimprint platform (YPL-NIL-SI400, China). The template/substrate stack was heated to 120 °C for 5 min with an imprinting pressure of 0.5 MPa to press the template and the COC film. Afterward, the heated stack was cooled down to the demolding temperature of 50 °C, and the COC film was peeled off from the glass template after releasing the pressure, leaving nanostructures replicated on the COC film.

C. Surface-enhanced Raman spectroscopy on directly imprinted soda-lime glass

Nanostructured glass substrates were first cleaned with DI water and dried in a nitrogen flow. Then, the samples were coated with a 70-nm thickness gold layer by thermal evaporation and were converted into SERS-active substrates. Such SERS samples feature a vertically coupling structure consisting of disks and holes with small gaps in between and show very high enhancement factor with optimized structural geometry. An aqueous solution (1 μL, 1.0 × 10⁻⁵ M) of R6G were dropped on the above gold-coated nanostructured glass substrates and dried under ambient conditions to leave a certain amount of analyte molecules on the SERS substrate surface. Then, the samples were excited by a 785 nm laser, and the Raman spectra of R6G were recorded using a QE65 Pro Raman spectrometer (Ocean Optics).

III. RESULTS AND DISCUSSION

The SEM images of master sapphire molds patterned with 300-nm depth, 650-nm pitch hexagonal nanopillar array and corresponding replicated hexagonal nanohole array on soda-lime glass substrates are shown in Figs. 3(a) and 3(b), respectively. The structure illustrated in Fig. 3(b) was fabricated using an imprinting pressure P = 9.6 MPa. It is evident from the results that the nanoholes in glass are the reversed copies of the nanopillars on the sapphire mold.

Besides these successful replications, a series of induction-heated thermal NIL experiments were carried out using different imprinting pressure to further investigate the effects of the imprinting pressure on the depth of imprinted nanoholes during our imprint process. For each set of experiments, the morphological characterizations were performed by SEM and
AFM and the depths of imprinted nanoholes were measured by AFM. Typical morphology and corresponding cross-sectional height profiles of the imprinted nanoholes on glass substrates with the imprinting pressures of 5.6, 8.6, and 11.2 MPa were shown in Figs. 4(a)–4(c), respectively. During the experiments, other imprinting parameters remained constant. The results showed that for a given pattern and constant processing parameters, the imprinted depth of nanoholes increases with the imprinting pressure.

We also investigated the effects of the imprinting temperature on the depth of imprinted nanoholes using numerical modeling based on the temperature-dependent viscosity and Young’s modulus of soda-lime glass, as shown in Figs. 5(a) and 5(b). Young’s modulus describes the elastic deformation of a solid material under tensile or compressive loading, while the viscosity is related to the states of glass at the specific temperature. Glass can be considered as elastic below T_g. When the temperature of glass goes beyond T_g, the viscosity decreases, so glass shows more viscoelastic characteristics, then glass gradually softens and its Young’s modulus decreases; therefore, directly imprinting on glass is possible. Using the temperature-dependent properties of glass, we then implemented numerical simulation to study the effects of imprinting temperature using a finite element method. The systematic illustration of the model was plotted in the inset of Fig. 5(c). The simulation model included a sapphire mold and a soda-lime glass substrate. For simplicity, the mold was assumed as ideally rigid. The glass substrate was considered as a viscoelastic material using the Kelvin-Voigt model, while the ambient temperature was set to be 820 °C and the viscosity of glass was 5 × 10^6 Pa s. Periodic boundary conditions were applied in the x- and y-directions. In the Kelvin-Voigt model, materials can be represented by a purely viscous damp and a purely elastic spring connected in parallel. Comparing with the Generalized Maxwell model, the Kelvin-Voigt model is more realistic for describing the creeping effect. Although the Kelvin-Voigt model does not describe the relaxation behavior after removal of stress, in the presented cases, the imprinting pressures are always removed when the temperature drops across the annealing temperature. Hence, the relaxation behavior is not important, and the Kelvin-Voigt model is favorable. The time-dependent deformation in the Kelvin-Voigt model upon a sudden constant stress σ_0 is

$$
\varepsilon_t = \frac{\sigma_0}{E} \left(1 - e^{-\lambda t}\right),
$$

where λ is the rate of relaxation.
\[ \lambda = \frac{E}{\eta}. \]

In the infinite time limit, the strain approaches a constant
\[ \varepsilon_{\infty} = \frac{\sigma_0}{E}. \]

Given the Young’s modulus \( E = 250 \, \text{kPa} \) and a viscosity \( \eta = 5 \times 10^6 \, \text{Pa s} \) at 820 °C it only costs 0.09 s to achieve 99% of \( \varepsilon_{\infty} \). The contribution of the creeping effect in lower temperature imprint is even less. Therefore, time in the transient simulation is set to be 30 s in all of the results.

Figure 5(c) plotted the depth of imprinted nanoholes as a function of imprinting pressure from the numerical modeling and experimental data, respectively. The curve indicated that the imprinted structure depth increases linearly with the imprinting pressure, and the relationship was confirmed by experiment results. Therefore, fulfilling the requirement for transferring higher-aspect-ratio structure on soda-lime glass needs higher imprinting pressure. Meanwhile, nanoholes with different depths for a given nanopillar-patterned template can be obtained simply by changing the imprinting pressure.

The imprint process was further numerically investigated by changing the imprinting temperature, in which imprinting pressure remained constant. The relationship of the imprinting temperature and depth of imprinted nanoholes under two different imprinting pressures, \( P = 5 \, \text{MPa} \) and \( P = 10 \, \text{MPa} \), respectively, was summarized in Fig. 5(d). The curves revealed that the depth of imprinted nanoholes increases dramatically when the imprinting temperature goes across the softening point of glass, which is attributed to the decreasing Young’s modulus.

The successfully fabricated hexagonal nanohole arrays on soda-lime glass substrates were used as templates to replicate nanopillar arrays on COC films through another thermal NIL process. The SEM images and the corresponding AFM-measured cross-sectional height profiles of nanoholes on the glass template and transferred nanopillars on the COC film are shown in Figs. 6(a)–6(d), respectively. Structures on the glass template were reliably replicated on the COC film. We also tested the glass templates for five imprinting cycles to investigate the durability of glass templates, and no noticeable defects, deformation, or collapse of features were found by investigating both the imprinted COC films and the glass templates after the fifth imprinting cycle under optical microscope and SEM, which indicated that the glass templates are reasonably robust and durable.

We also demonstrated the application of using nanostructured glass substrates to fabricate SERS-active substrates. In our experiment, the SERS-active substrate was prepared by evaporating a 70-nm thickness layer of gold onto a soda-lime glass.
glass substrate imprinted with an 87-nm depth hexagonal nanohole array [Fig. 7(a)]. Then, we dropped 1 μl of 1.0 × 10⁻⁵ M R6G aqueous solution on the above gold-coated nanostructured substrate and dried it in ambient conditions for 12 h to leave a certain amount of R6G molecules on the SERS substrate. Afterward, we measured the Raman spectra excited by a 785 nm laser. As a reference, we also investigated the Raman spectra of the R6G on a flat glass substrate coated with 70-nm-thick gold. Figure 7(b) summarized the Raman spectra measured from these samples. It is extremely difficult to obtain a clear Raman spectrum for such small amount of R6G on the unpatterned glass as the signal is too weak. Compared with the reference sample, considerable enhancement on the R6G signature was obtained on the gold-coated nanostructured substrate for the Raman modes of R6G at 614, 775, 1186, 1316, and 1366 cm⁻¹ excited by a 785 nm laser.

We then implemented a finite-difference time-domain (FDTD) calculation to further investigate the enhancement behavior of Raman signal in our experiment. For simplicity, we assumed a uniform hexagonal unit cell for the FDTD calculation. The \( |E|^2 \) distribution of the gold-coated nanostructured glass substrate is shown in Fig. 7(c). The excitation wavelength was chosen at 785 nm as used in our experiment. It can be observed that enhanced electrical field is localized around the edge, which is believed to be caused by the surface plasmon polariton (SPP) and the coupling between SPP of the top metal nanoholes and localized surface plasmonic resonance of bottom metal nanodisk. Although the structures in this work were limited to 650-nm pitch hexagonal nanohole arrays due to the availability of the mold we used in the imprint process, with further design and optimization, such metallic nanostructures fabricated on directly imprinted glass substrates can be utilized as high-performance sensors based on surface enhanced spectroscopy techniques.

IV. CONCLUSIONS

In summary, we developed an efficient method for faithfully and readily transferring nanopatterns onto soda-lime glass substrates by induction-heated high-temperature thermal nanoimprint process using sapphire molds. We experimentally and numerically studied the processing parameters and replication fidelity of transferring nanostructures on soda-lime glass substrates during imprint process. Nanohole arrays were successfully and faithfully transferred on soda-lime glass substrates using 650-nm pitch hexagonal nanopillar array patterned sapphire molds. Our experiment and modeling results confirmed that the depth of imprinted nanoholes increases linearly with imprinting pressure when other processing parameters remain constant during this imprinting process of soda-lime glass substrates. As an application, the imprinted nanostructures on glass substrates were further transferred onto thermoplastic COC films through another conventional thermal NIL process using the nanostructured glass substrates as secondary templates. The replicated reversed nanostructures on the COC film exhibited high fidelity compared with
the original patterns on glass templates. Moreover, by depositing a thin layer of Au film on nanostructured soda-lime glass substrates, highly sensitive SERS-active substrates were fabricated and showed good enhancement for R6G sensing.

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